



**ELECTRONIC COPY**

LG684511036  
Report verification at igi.org



February 18, 2025

IGI Report Number **LG684511036**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **7.57 X 5.58 X 3.73 MM**

**GRADING RESULTS**

Carat Weight **1.33 CARAT**

Color Grade **D**

Clarity Grade **VVS 1**

February 18, 2025

IGI Report Number **LG684511036**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**

Measurements **7.57 X 5.58 X 3.73 MM**

**GRADING RESULTS**

Carat Weight **1.33 CARAT**

Color Grade **D**

Clarity Grade **VVS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

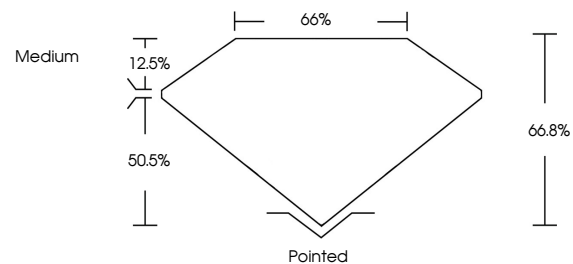
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG684511036**

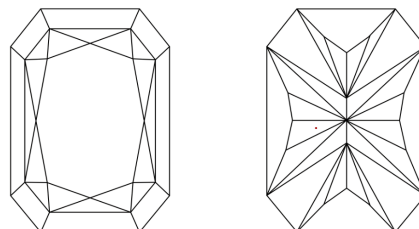
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

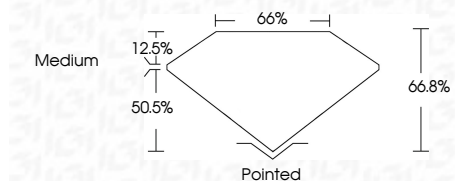
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG684511036**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



February 18, 2025  
IGI Report No LG684511036  
CUT CORNERED RECT. MODIFIED BRILLIANT

7.57 X 5.58 X 3.73 MM

1.33 CARAT  
D

Color Grade  
D

Clarity Grade  
VVS 1

Depth  
50.5%

Table  
12.5%

Girdle  
Medium

Culet  
Pointed

Polish  
EXCELLENT

Symmetry  
EXCELLENT

Fluorescence  
NONE

Inscription(s)  
IGI LG684511036

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa